



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: Patton et al.

Atty Dkt No.: NOVLP016C1/NVLS-000403C1

Application No.: 10/693,223

Examiner: Nguyen, H.

Filed: October 24, 2003

Group: 2812

Title: SEQUENTIAL STATION TOOL FOR  
WET PROCESSING OF  
SEMICONDUCTOR WAFERS

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as first-class mail on August 31, 2005 in an envelope addressed to the Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

Signed: \_\_\_\_\_

Tara Hayden

**RESCISSION OF PREVIOUS NONPUBLICATION REQUEST**

**(35 U.S.C. 122(b)(2)(B)(ii))**

**AND, IF APPLICABLE,**

**NOTICE OF FOREIGN FILING**

**(35 U.S.C. 122(b)(2)(B)(iii))**

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A request that the above-identified application not be published under 35 U.S.C. 122(b) (nonpublication request) was included with the above-identified application on filing pursuant to 35 U.S.C. 122(b)(2)(B)(i). The nonpublication request is hereby rescinded.

If a notice of foreign or international filing is or will be required by 35 U.S.C. 122(b)(2)(B)(iii) and 37 C.F.R. 1.213(c), such notice is hereby provided. This notice is being provided no later than forty-five (45) days after the date of such foreign or international filing.

Respectfully submitted,  
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